



**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Manabu NAKAMURA et al.**

Art Unit: **2891**

Application Number: **10/659,748**

Examiner: **Bradley Smith**

Filed: **September 11, 2003**

Confirmation Number: **3468**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING  
GATE OR TUNNEL INSULATION FILM**

Attorney Docket Number: **031140**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 11, 2008

Sir:

In response to the Office Action dated August 10, 2007, the response date of which having been extended by three months to February 10, 2008, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.